

Serial No. 10/502,465

Atty. Docket 30848/40323

IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE

Serial No. : 10/502,465  
Confirmation : 3973

Applicants : Nassiopoulou et al.  
371 (c) date : July 23, 2004

Title: LOW POWER SILICON  
THERMAL SENSORS AND  
MICROFLUIDIC DEVICES BASED ON  
THE USE OF POROUS SEALED AIR  
CAVITY TECHNOLOGY OR  
MICROCHANNEL TECHNOLOGY

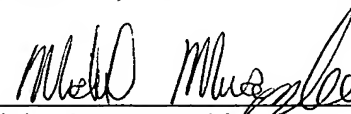
Art Unit : 2878  
Examiner : ROSENBERGER,  
Frederick F.

Atty Docket : 30848/40323  
Customer No. : 04743

) Date of Deposit:  
) November 17, 2005  
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) Commissioner for Patents  
) P.O. Box 1450  
) Alexandria, VA 22313-1450  
)

)   
) Michael Muczynski

**AMENDMENT "A"**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir: ,

Please amend this application as specified on the following pages.

11/22/2005 FFANAEIA 00000092 10502465

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